

ABSTRACTMETHOD FOR MANUFACTURE OF A DEVICE

The invention relates to a method for the manufacture of a device with the following steps: (a) formation of a base body (1) having two external electrodes opposite each other, and (b) adjustment of the resistance of the base body (1) measured between the external electrodes, to a given target value by chemical etching of portions of the base body (1). The method has the advantage that mechanical machining methods or machining the base body (1) can be dispensed with which in particular makes possible the processing of very small devices.

Figure 1